

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re PATENT APPLICATION of

Ki-Hwan Park et al.

Group Art Unit: 1746

Application No. 10/695,770

Examiner: El Arini, Zeinab

Filed: October 30, 2003

Confirmation No. 6935

For: METHOD OF AND APPARATUS FOR CLEANING SEMICONDUCTOR WAFERS

**RESPONSE TO ELECTION/RESTRICTION REQUIREMENT**

U.S. Patent and Trademark Office

**e-Filing**

Randolph Building

401 Dulany Street

Alexandria VA 22314

Sir:

In response to the Office Action of September 30, 2005, Applicants elect the invention of Group I, Claims 1-4 and 10. The election is without traverse.

Respectfully submitted,

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